

Form PTO-1449 (MODIFIED)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 039153-0450 (G1155)		SERIAL NO. Unknown		
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				APPLICANT Lukanc et al.		FILING DATE Unknown		
				GROUP ART UNIT Unknown				
				U.S. PATENT DOCUMENTS				
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE	
	A1	09/772,327		Todd Lukanc	430	5	01/30/2001	
	A2	6,228,539 B1	05/08/2001	Wang et al.	430	5		
	A3	5,858,580	01/12/1999	Wang et al.	430	5		
	A4	5,807,649	09/15/1998	Liebmann et al.	430	5		
	A5	5,573,890	11/12/1996	Spence	430	311		
	A1	6,534,224	3/18/03	Todd Lukanc	430	5		
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	A6	Levenson et al., "Improving Resolution in Photolithography with a Phase-Shifting Mask," IEEE Transactions On Electron Devices, Vol. ED-29, No. 12, December 1982, pp. 1828-36.						
	A7	Lin, B. J., "Phase-Shifting Masks Gain an Edge," Circuits & Devices, March 1993, pp. 28-35.						
EXAMINER 		DATE CONSIDERED 8/27/03						
* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include any copy of this form with next communication to applicant.								